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| 専門分野 Research field | Corporate Management, Strategic Planning, Business Strategy, or Trademark and Industrial Design Practice (Specifically focusing on Corporate Brand Management and Strategy) |
| 待遇・ 募集人員 Job titles and number of positions | Job title and Employment status: Lecturer (Full-time, Nontenured) <ul style="list-style-type: none"> ・ For nontenured position: maximum of 5 year's contract and treatment is subject to the university regulations ・ The contract is either renewable or changed to tenure depending on evaluation of applicant's work (teaching and research). Number of positions: 1 |
| 所属 Department | Faculty of Intellectual Property |
| 応募資格 Qualifications | <ol style="list-style-type: none"> ① Applicant must have good understanding and respect for the "Spirit of foundation" and "education policy" of the institution. ② A master's degree in the area of 学位(分野) or some closely related fields. ③ After appointment, the applicant must reside in an area easily accessible to all three campuses (Omiya/Asahi-ku, Umeda/Kita-ku, Hirakata/Hirakata-city) |
| 担当科目 Courses to be Taught | Courses in Brand Management, Business Strategy, History of Technology, or Trademark and Design IP |
| 応募締切 Application period | Applications must reach us no later than Monday, June 1, 2026. |
| 着任時期 Starting date | April 1, 2027 |
| 応募書類 Application documents | <ol style="list-style-type: none"> (1) Curriculum vitae (please use institution's designated format) (2) List of research and teaching achievements (please use an institution's designated format) (3) Three recent major publications (copies are acceptable) (4) Essay (maximum of 1,000 characters in Japanese, 1-A4 page, has to include your name) Please choose a topic from below "Describe your practice in detail to enhance education" "Your goals after appointment" (5) A return envelope for your result (N3 envelop with returning address written and 110-yen stamp attached) <ol style="list-style-type: none"> ① Please use an institution's designated format for CV and your list of research, and teaching achievements. The format is available on institution's job posting website. ② All documents have to be printed A4 papers and clipped (stapling is not acceptable). ③ Any personal information applicants provided will not be used other than for the selection process (personal information provided by the applicant who passed will be used for further hiring processes) ④ Any documents are not returnable. All documents provided will be discarded by the institution's responsibility. |

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| | ⑤ If you wish for documents to be returned, please enclose a delivery payment invoice with the address and name stated |
| 提出先 Submission | Osaka Institute of Technology General affairs, President's Office 5-16-1 Omiya, Asahi-ku, Osaka 535-8585 Japan Please write “学科・応募分野” in red on the front of the envelope. When using postal services, please send applications through simple registered mail. |
| 選考方法 Application selection | Applicants who pass the document screening will be invited to come to an interview followed by a designated screening process. Interviews are planned to be held late-June. The date of interview will be notified only to applicants who have passed the screening. |
| 問合せ先 Contact detail | E-mail: norimasa.sugiyama@oit.ac.jp Phone: +81-6-6954-4163 |

〈参考〉職階別の英語表記

- ・教授 : Professor
- ・准教授 : Associate Professor
- ・講師 : Assistant Professor
- ・助手 : Research Associate